

## Nano4me.org Video Download

ESC 212: Basic Nanotechnology Processes

**Unit 2: An Introduction to Uses of Plasmas in Processing**



### **Lecture 4**

**Length:** 34:53

This video will cover:

- Subtractive Processes
- Plasma Assisted Cleaning
- Dry Etching

Thank You For Watching!

What did you think? [Email](#) Bob Ehrmann with your feedback.

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